Richard T. Ogawa, Reg. No. 37,692 (650) 326-2400
Attorney Docket No.: 021653-000400US Applicant: Pai, Chi Hong
Title: METHOD AND STRUCTURE TO FORM CAPACITOR IN COPPER
DAMASCENE PROCESS FOR INTEGRATED CIRCUIT DEVICES
Replacement Drawings Sheet 1 of 1



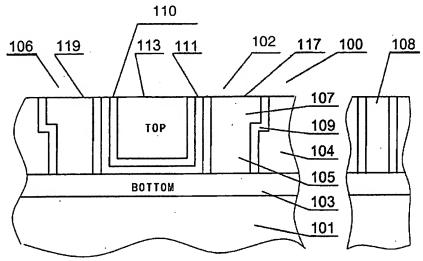


FIG. 1A

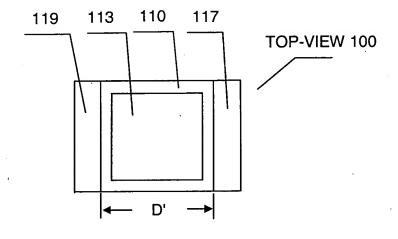


FIG. 1B